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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Mitsuru TANABE)
Japanese Priority Application No. 2000-119604) Attn: Applications
Japanese Priority Date: April 20, 2000) Branch
For: MICROSTRIP LINE, METHOD FOR)
FABRICATING THE SAME, INDUCTOR)
ELEMENT, AND RF SEMICONDUCTOR)
DEVICE) Date: April 20, 2001

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents

Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some of the references listed on the attached Form PTO-1449 are discussed in the specification of the subject application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


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